

[0079] If desired, the different functions discussed herein may be performed in a different order and/or concurrently with each other. Furthermore, if desired, one or more of the above-described functions may be optional or may be combined.

[0080] Although various aspects of the invention are set out in the independent claims, other aspects of the invention comprise other combinations of features from the described embodiments and/or the dependent claims with the features of the independent claims, and not solely the combinations explicitly set out in the claims.

[0081] It is also noted herein that while the above describes example embodiments of the invention, these descriptions should not be viewed in a limiting sense. Rather, there are several variations and modifications which may be made without departing from the scope of the present invention as defined in the appended claims.

1. A method comprising
monitoring deformation of a flexible electronic apparatus;
wherein said monitoring of deformation comprises
detecting changes in space within the apparatus between at
least two measurement points; and
determining degree of deformation of the apparatus based
on the detected changes in the space within the apparatus
between the at least two measurement points.
2. A method according to claim 1, wherein said at least two
measurement points reside in at least two different parts of the
apparatus, wherein said at least two parts are configured to
move in relation to one another to allow deformation of the
flexible electronic apparatus.
3. A method according to claim 1, wherein said at least two
measurement points reside on different surfaces of one
deforming part of the apparatus.
4. A method according to claim 1, wherein said at least two
measurement points reside inside the apparatus.
5. A method according to claim 1, wherein at least one of
the two measurement points resides on a cover part of the
apparatus.
6. A method according to claim 1, wherein said at least two
measurement points are different points in time domain.
7. A method according to claim 1, wherein said detection of
changes in space within the apparatus comprises detecting
relative movement of the at least two measurement points in
relation to one another.
8. A method according to claim 1, wherein said detection of
changes in space within the apparatus comprises detecting a
change in distance between the at least two measurement
points.
9. A method according to claim 1, wherein said detection of
changes in space within the apparatus comprises detecting a
gap between the at least two measurement points.
10. A method according to claim 1, wherein said detection
of changes in space within the apparatus comprises detecting
a contact between the at least two measurement points.

11. A method according to claim 1, wherein said detecting
of changes in space within the apparatus comprises detecting
a change in forces experienced between the at least two mea-
surement points.

12. A method according to claim 1, wherein said detection
of changes in space within the apparatus comprises detecting
changes in pressure experienced within the apparatus.

13. A method according to claim 1, wherein said apparatus
comprises a cavity filled with any one of a fluid and a gas
within the apparatus and said detection of changes in space
within the apparatus comprises detecting changes in pressure
experienced by any one of the fluid and the gas within the
cavity.

14. A method according to claim 1, wherein the apparatus
comprises elastic material between the at least two measure-
ment points and said detection of changes in space within the
apparatus comprises detecting changes within the elastic
material.

15. A method according to claim 1, wherein said detection
of changes in space within the apparatus is performed by
using contactless measurement technology.

16. A method according to claim 1, wherein said apparatus
comprises a touch screen and said detection of changes in
space within the apparatus comprises detecting changes in
capacitive environment of the touch screen.

17. An apparatus comprising:
an apparatus structure configured to allow deformation of
the apparatus;
detection equipment configured to detect changes in space
within the apparatus between at least two measurement
points; and
a processing unit configured to determine degree of defor-
mation of the apparatus based on the detected changes in
the space within the apparatus between the at least two
measurement points.

18. An apparatus according to claim 17, wherein said
detection equipment is configured to detect changes in dis-
tance between the at least two measurement points.

19. An apparatus according to claim 17, wherein said
detection equipment is configured to detect a change in forces
caused between the at least two measurement points.

20. An apparatus according to claim 17, wherein said
detection equipment comprises contactless measurement
equipment.

21. An apparatus according to claim 17, wherein said
detection equipment comprises at least one magnet and mag-
netometer pair.

22. An apparatus according to claim 17, wherein said
detection equipment comprises at least one capacitive sensor.

23. An apparatus according to claim 17, wherein said
detection equipment comprises at least one inductive sensor.

24. An apparatus according to claim 17, further comprising
at least one touch screen configured to provide a user interface
and said touch screen is configured to operate as the detection
equipment and to detect changes in capacitive environment of
the touch screen changes in space within the apparatus.

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